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## \*\* CONTINUING DATA \*\*\*\*\*

in none

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-221929 07/30/2002

in none

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR  COUNTRY JAPAN	SHEETS  DRAWING 11	TOTAL  CLAIMS 17	INDEPENDENT  CLAIMS 4
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>Wille</i>	Initials		

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## TITLE

Ion beam apparatus, ion beam processing method and sample holder member

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees
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